

FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO. ATMI-668		SERIAL NO. 10/792,038	
JUL 02 2004 INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)				APPLICANT Melissa K. Rath, et al.			
				FILING DATE March 3, 2004		GROUP 1756	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
le	AA	6,276,372	8/21/2001	Lee	134	1.3	
le	AB	6,242,400	6/5/2001	Lee	510	176	
le	AC	6,110,881	8/29/2000	Lee	510	175	
le	AD	5,709,756	1/20/1998	Ward, et al.	134	1.3	
le	AE	5,419,779	5/30/1995	Ward	134	38	
le	AF	20020128164	9/12/2002	Hara, Yasushi; et al.	510	175	11/30/2001
le	AG	6,329,118	12/11/2001	Hussein, et al.	430	270.1	
le	AH	10/389,214		Minsek, et al.	430	32A	3/14/2003
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES NO
							X (abstract only)
<b>OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)</b>							
le	AI	Ito, "Dissolution Behavior of Chemically Amplified Resist Polymers for 248, 193-and 157 -nm Lithography, IBM J. Res. & Dev., Vol. 45 No. 5, (Sept. 2001)					
le	AJ	M. Hussein, et al. "A Novel Approach to Dual Damascene Patterning", Intel Corporation, Portland Technology Development, Hillsboro, OR					
Continue on Page							
EXAMINER Hoa Van Le					DATE CONSIDERED 25 May 2005		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							